

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 4, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG668401978

LABORATORY GROWN DIAMOND

EMERALD CUT

7.71 X 5.10 X 3.07 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.24 CARAT

D

INTERNALLY FLAWLESS

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence


EXCELLENT

EXCELLENT

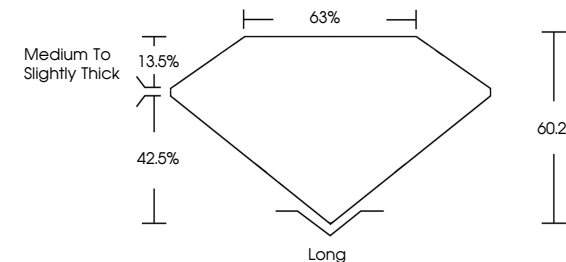
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Inscription(s)

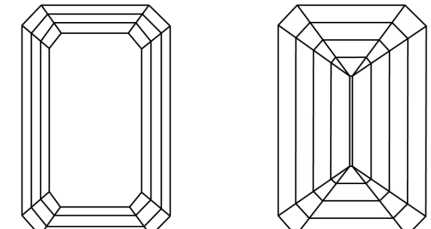
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG668401978

PROPORTIONS



CLARITY CHARACTERISTICS




KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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
EXCELLENT

EXCELLENT

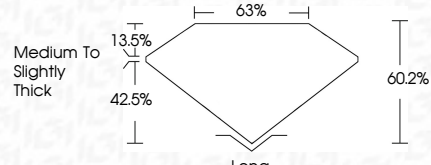
NONE

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PROPORTIONS



COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

IF

VS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Internally Flawless

Very Very Slightly Included

Very Slightly Included


Slightly Included

Included

INTERNATIONAL GEMOLOGICAL INSTITUTE

IGI

1975



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December 4, 2024

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EMERALD CUT

7.71 X 5.10 X 3.07 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Medium to Slightly Thick

Length

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

1.24 CARAT

D

EXCELLENT

EXCELLENT

NONE

IGI LG668401978

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